

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

e Patent Application of

MAIL STOP AMENDMENT

Koji HIROTA et al.

Group Art Unit: 1775

Application No.: 10/500,846

Examiner: Michael E. La Villa

Filed: July 7, 2004

Confirmation No.: 8733

For: METAL LAMINATE AND ETCHING

METHOD THEREFOR

## **AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated March 23, 2006, please amend the above-identified patent application as follows: